

Title (en)

MICRO-ELECTRO-MECHANICAL SWITCH FOR SWITCHING AN ELECTRICAL SIGNAL, MICRO-ELECTRO-MECHANICAL SYSTEM, INTEGRATED CIRCUIT AND METHOD FOR PRODUCING AN INTEGRATED CIRCUIT

Title (de)

ELEKTROMECHANISCHER MIKROSCHALTER ZUR SCHALTUNG EINES ELEKTRISCHEN SIGNALS, MIKROELEKTROMECHANISCHES SYSTEM, INTEGRIERTE SCHALTUNG UND VERFAHREN ZUR HERSTELLUNG EINER INTEGRIERTEN SCHALTUNG

Title (fr)

DISPOSITIF MICRO-ÉLECTROMÉCANIQUE (MEMS) POUR COMMUTER UN SIGNAL ÉLECTRIQUE, SYSTÈME, CIRCUIT INTÉGRÉ ET PROCÉDÉE DE FABRICATION DU CIRCUIT INTÉGRÉ

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Application

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Abstract (en)

[origin: WO2011069988A2] The invention relates to a microelectromechanical system (MEMS) (100, 200) having an electromechanical microswitch (1) for switching an electrical signal (S), in particular a radio frequency signal (RFMEMS), in particular in the GHz range. Said system comprises, according to the invention: a multi-level conductor stack (102, 202) disposed on a substrate (101, 201), the conductors (111-115, 211-215) thereof being insulated from each other in different conductor levels (M1-M5) by means of electrically insulating layers (103, 203) and electrically connected to each other by means of interlayer contacts (104, 204), the electromechanical switch (1) integrated in a recess (105, 205) of the multilevel conductor stack (102, 202) and having a contact link (10), a counter-contact (20), and at least one drive electrode (30, 50) for the contact link (10), wherein the contact link (10), the counter-contact (20), and the at least one drive electrode (30, 50) each are part of a conductor level (M1-M5) of the multilevel conductor stack (102, 202).

IPC 8 full level

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